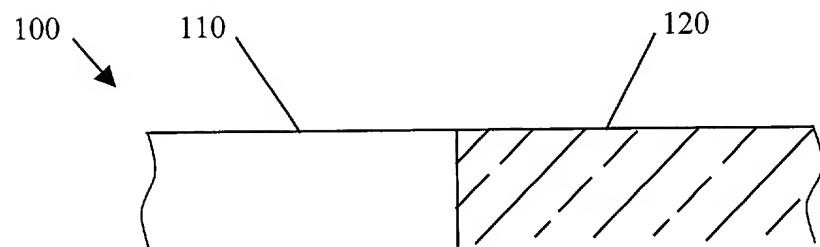
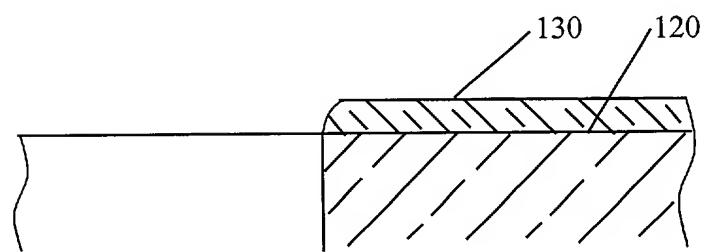


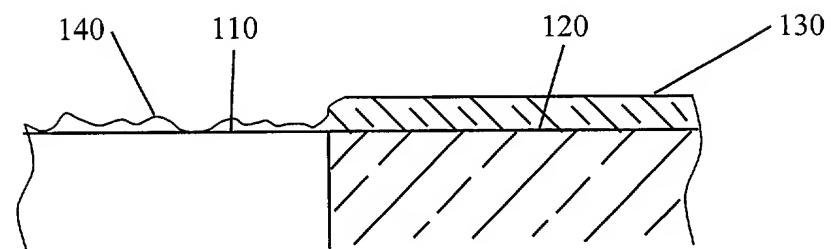
**FIGURE 1A (PRIOR ART)**



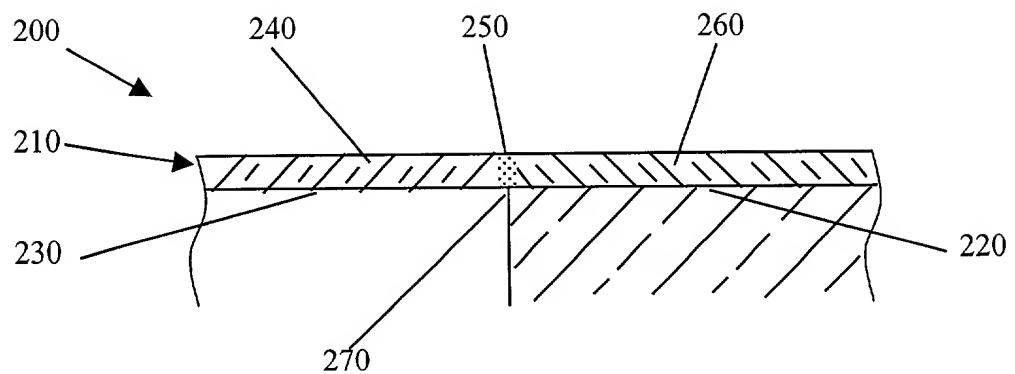
**FIGURE 1B (PRIOR ART)**



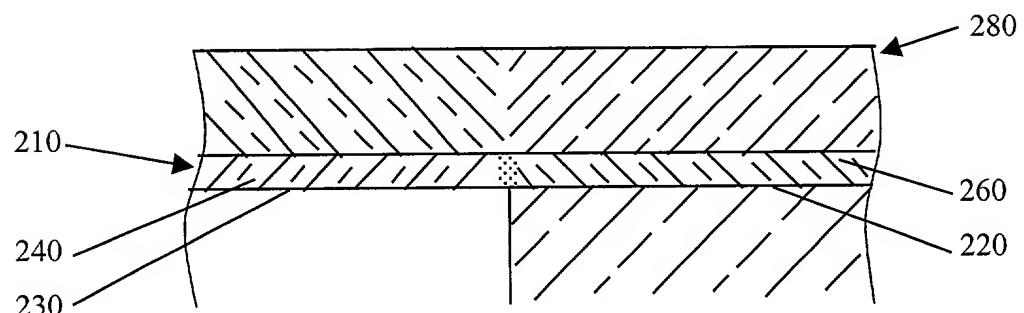
**FIGURE 1C (PRIOR ART)**



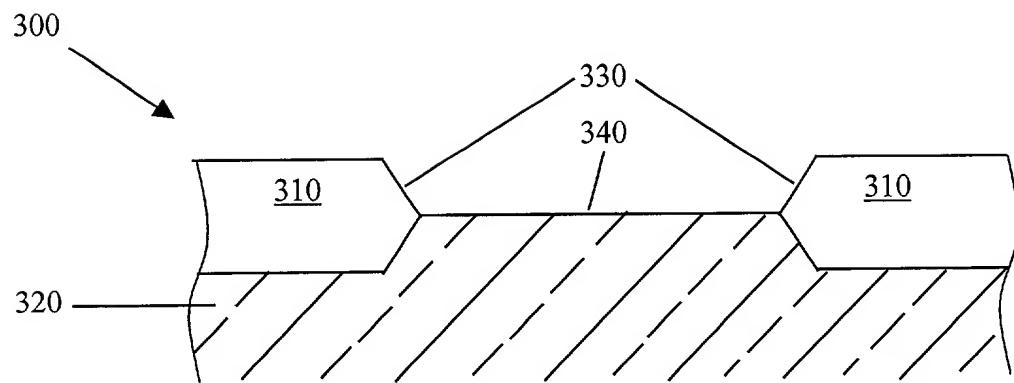
**FIGURE 2A**



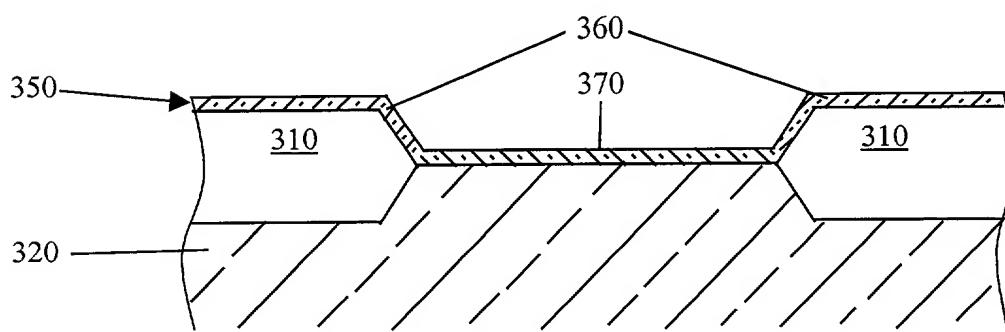
**FIGURE 2B**



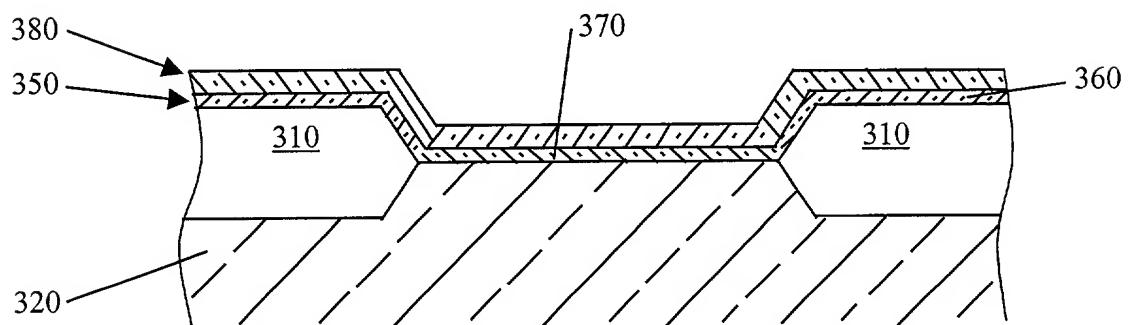
**FIGURE 3A**



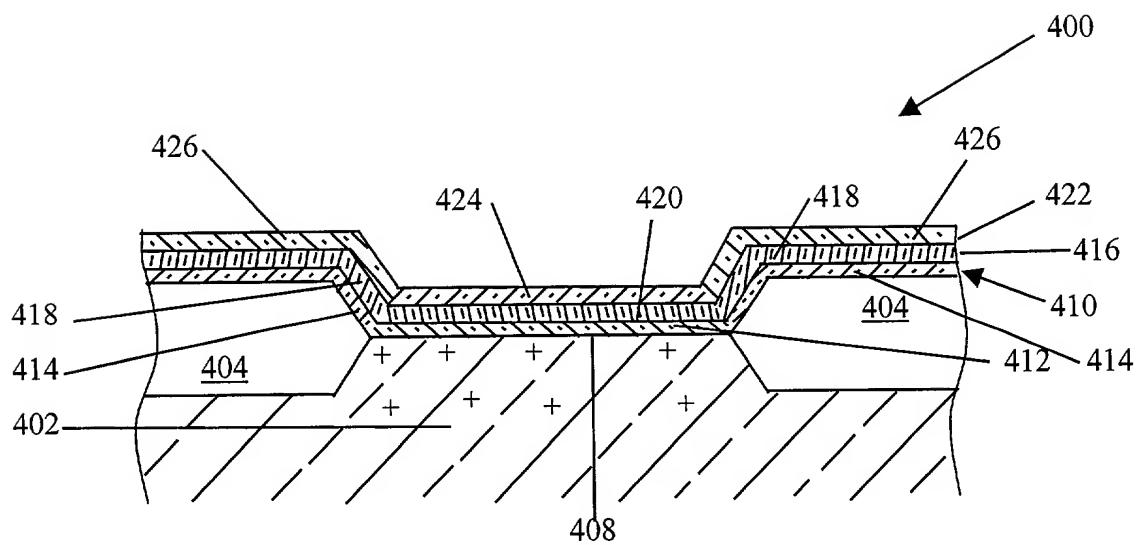
**FIGURE 3B**



**FIGURE 3C**

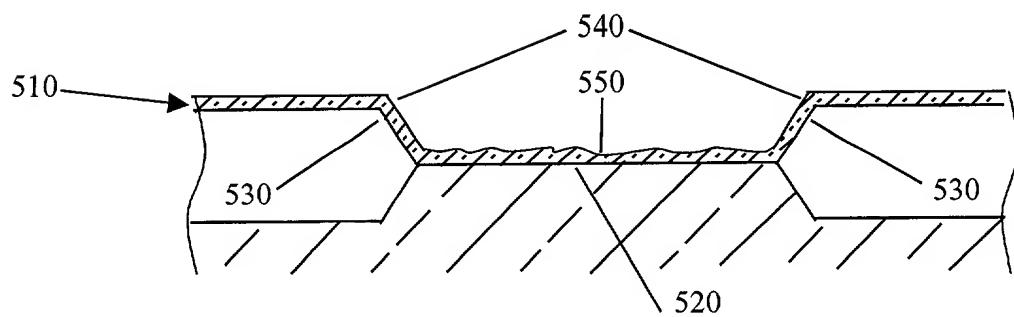


**FIGURE 4**

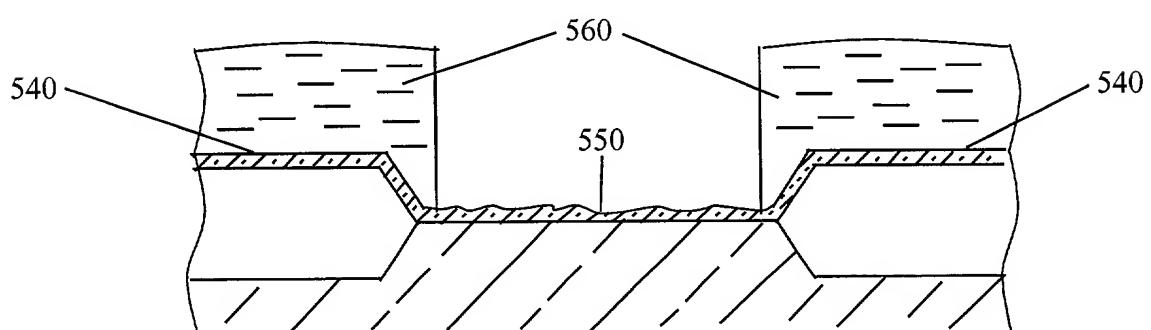


1920. The first signs of the new epoch were visible in the year 1917, when the Russian Revolution overthrew the Tsarist autocracy.

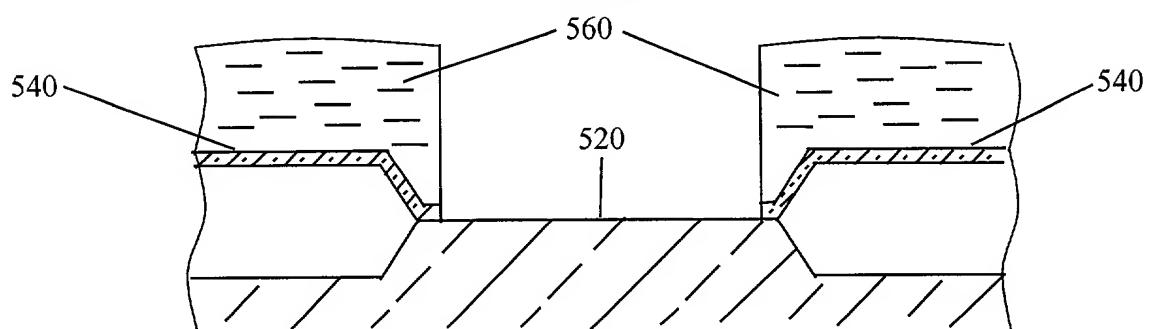
**FIGURE 5A**



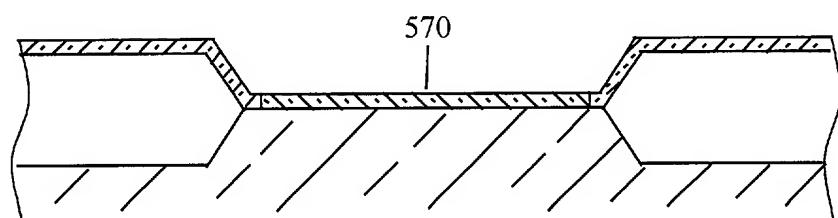
**FIGURE 5B**



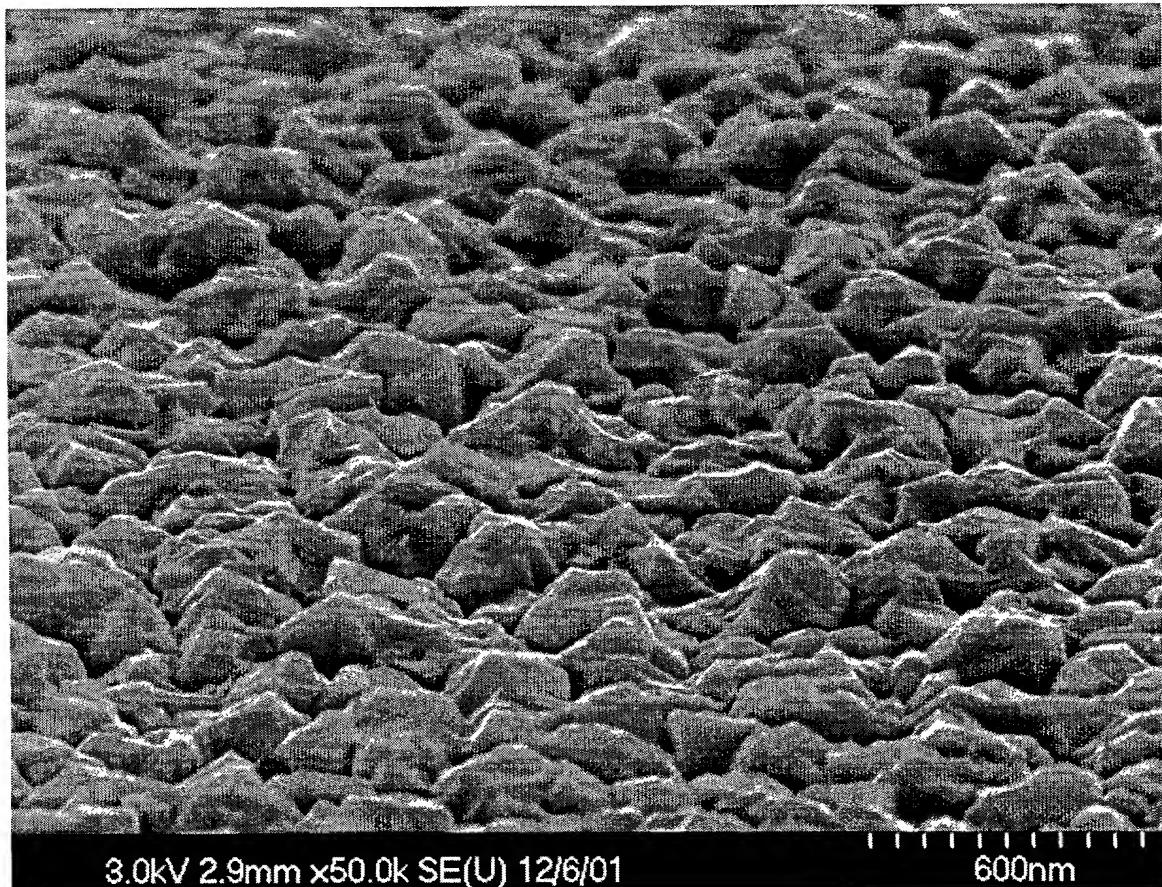
**FIGURE 5C**



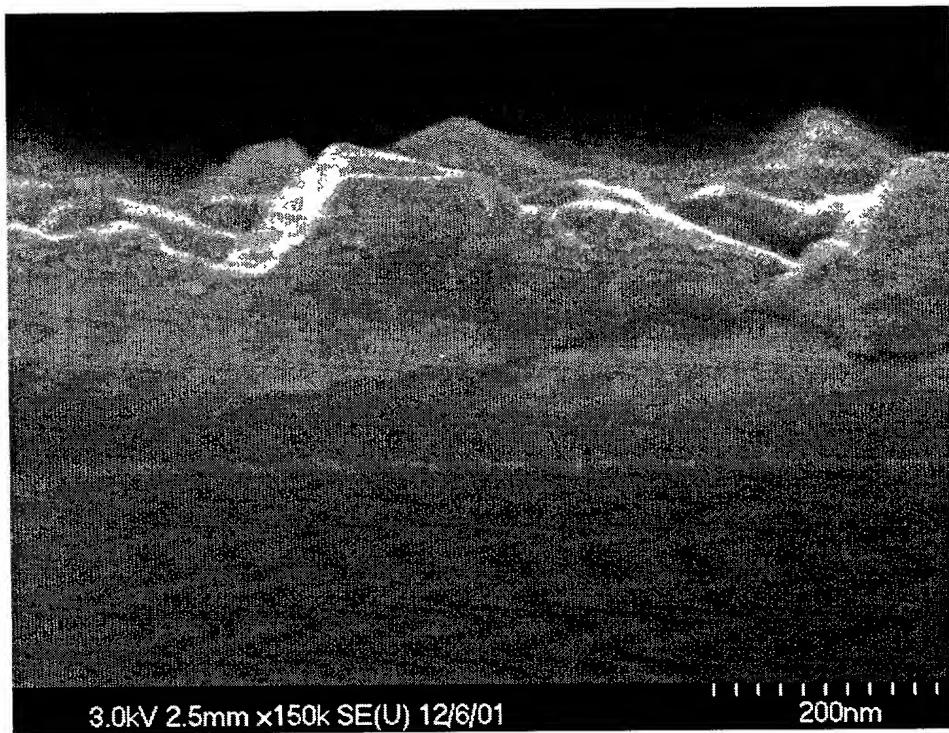
**FIGURE 5D**



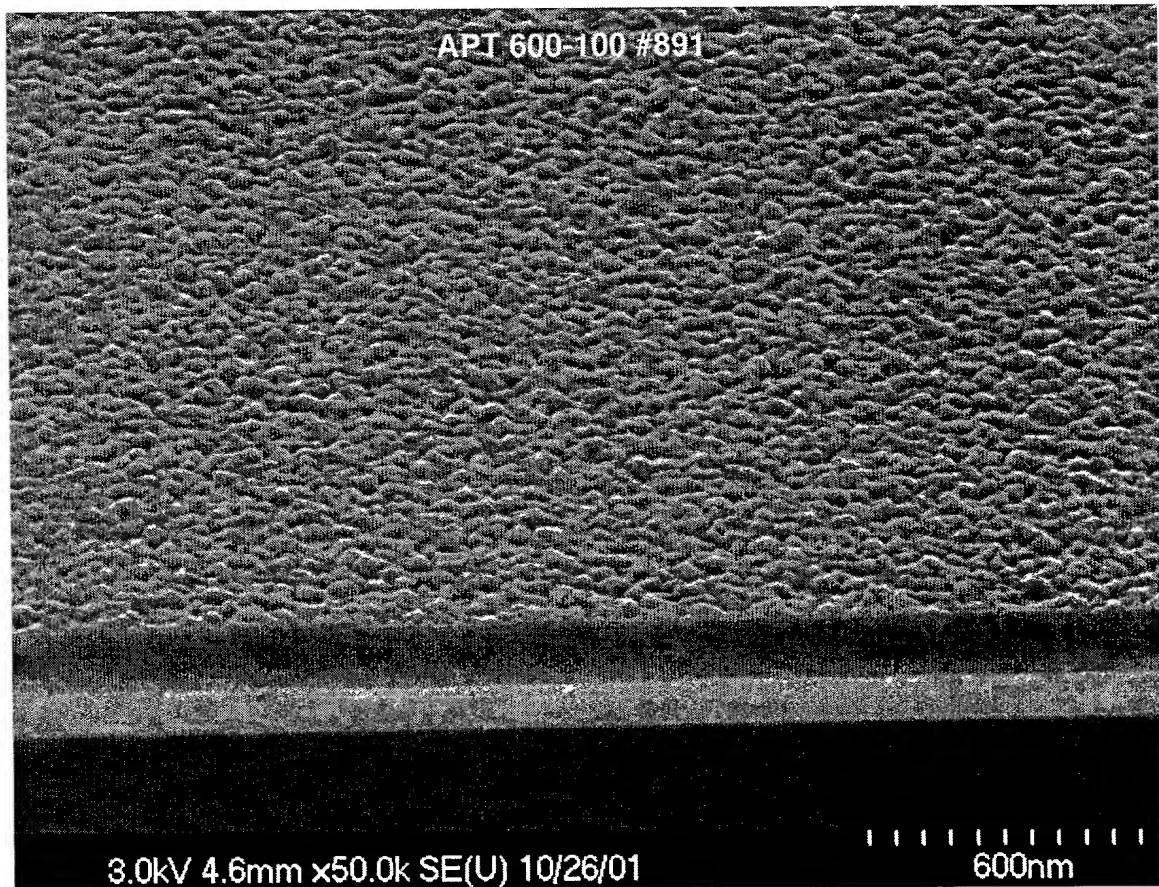
**FIGURE 6**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Silane and Germane**



**FIGURE 7**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Silane and Germane**



**FIGURE 8**  
SEM Photomicrograph of Si-Ge Film Deposited Using Trisilane and Germane



**FIGURE 9**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Trisilane and Germane**

